

Ref #	Hits	Search Query	DBs	Default Operator	Plurals	Time Stamp
S1	2	("6815162").PN.	US-PGPUB; USPAT; USOCR; EPO; JPO; DERWENT; IBM_TDB	OR	OFF	2006/01/11 09:32
S2	696	(@ad<="20010312") and (438/745.cds.)	US-PGPUB; USPAT; USOCR; EPO; JPO; DERWENT; IBM_TDB	OR	ON	2006/01/12 11:05
S3	34	(@ad<="20010312") and ((porous) adj (silicon)) and ((hydrogen) same (terminat\$4)) and (organic) and (process\$4)	US-PGPUB; USPAT; USOCR; EPO; JPO; DERWENT; IBM_TDB	OR	ON	2006/01/11 10:49
S4	6	(@ad<="20010312") and ((porous) adj (silicon)) and ((hydrogen) same (terminat\$4)) and (organic) and (process\$4) and (aldehydes)	US-PGPUB; USPAT; USOCR; EPO; JPO; DERWENT; IBM_TDB	OR	ON	2006/01/11 12:08
S5	3	(@ad<="20010312") and ((porous) adj (silicon)) and ((hydrogen) same (terminat\$4)) and (organic) and ((thermal) adj (process\$4)) and (aldehydes)	US-PGPUB; USPAT; USOCR; EPO; JPO; DERWENT; IBM_TDB	OR	ON	2006/01/11 10:15
S6	3110	(@ad<="20010312") and (silicon) and ((hydrogen) same (terminat\$4)) and (organic) and (process\$4)	US-PGPUB; USPAT; USOCR; EPO; JPO; DERWENT; IBM_TDB	OR	ON	2006/01/11 10:50
S7	702	(@ad<="20010312") and (silicon) and ((hydrogen) same (terminat\$4)) and (organic) and (process\$4) and (aldehyde)	US-PGPUB; USPAT; USOCR; EPO; JPO; DERWENT; IBM_TDB	OR	ON	2006/01/12 08:07
S8	140	(@ad<="20010312") and (silicon) and ((hydrogen) same (terminat\$4)) and (organic) and (process\$4) and (aldehyde) and ((thermal\$3) with (process\$3))	US-PGPUB; USPAT; USOCR; EPO; JPO; DERWENT; IBM_TDB	OR	ON	2006/01/11 10:51
S9	19	(@ad<="20010312") and (silicon) and ((hydrogen) same (terminat\$4)) and (organic) and (process\$4) and (aldehyde) and ((thermal\$3) with (process\$3)) and (stabl\$4) and (impurit\$4)	US-PGPUB; USPAT; USOCR; EPO; JPO; DERWENT; IBM_TDB	OR	ON	2006/01/11 10:52
S10	702	(@ad<="20010312") and ((silicon)) and ((hydrogen) same (terminat\$4)) and (organic) and (process\$4) and (aldehydes)	US-PGPUB; USPAT; USOCR; EPO; JPO; DERWENT; IBM_TDB	OR	ON	2006/01/11 12:08

S11	702	(@ad<="20010312") and (silicon) and ((hydrogen) same (terminat\$4)) and (organic) and (process\$4) and (aldehydes)	US-PGPUB; USPAT; USOCR; EPO; JPO; DERWENT; IBM_TDB	OR	ON	2006/01/11 12:12
S12	36	(@ad<="20010312") and (silicon) and ((hydrogen) same (terminat\$4)) and (organic) and ((thermal\$4) adj2 (process\$4)) and (aldehydes)	US-PGPUB; USPAT; USOCR; EPO; JPO; DERWENT; IBM_TDB	OR	ON	2006/01/11 12:13
S13	9	(@ad<="20010312") and (silicon) and ((hydrogen) same (terminat\$4)) and (organic) and (process\$4) and (aldehyde) and ((rins\$4) with (ethanol))	US-PGPUB; USPAT; USOCR; EPO; JPO; DERWENT; IBM_TDB	OR	ON	2006/01/12 08:09
S14	3	(@ad<="20010312") and (438/745.ccls.) and ((rins\$4) with (ethanol))	US-PGPUB; USPAT; USOCR; EPO; JPO; DERWENT; IBM_TDB	OR	ON	2006/01/12 10:05
S15	51	(@ad<="20010312") and ((ethyl) adj (undecylenate))	US-PGPUB; USPAT; USOCR; EPO; JPO; DERWENT; IBM_TDB	OR	ON	2006/01/12 11:04
S16	185	(@ad<="20010312") and ((electrochemical\$4) adj (etch\$4)) and ((porous) adj (silicon))	US-PGPUB; USPAT; USOCR; EPO; JPO; DERWENT; IBM_TDB	OR	ON	2006/01/12 11:06
S17	4	(@ad<="20010312") and ((electrochemical\$4) adj (etch\$4)) and ((porous) adj (silicon)) and (438/745.ccls.)	US-PGPUB; USPAT; USOCR; EPO; JPO; DERWENT; IBM_TDB	OR	ON	2006/01/12 11:12
S18	0	(@ad<="20010312") and ((electrochemical\$4) adj (etch\$4)) and ((porous) adj (silicon)) and (438/745.ccls.) and ((hydrogen) adj (terminat\$4))	US-PGPUB; USPAT; USOCR; EPO; JPO; DERWENT; IBM_TDB	OR	ON	2006/01/12 11:13
S19	0	(@ad<="20010312") and ((electrochemical\$4) adj (etch\$4)) and ((porous) adj (silicon)) and (438/745.ccls.) and ((hydrogen) same (terminat\$4))	US-PGPUB; USPAT; USOCR; EPO; JPO; DERWENT; IBM_TDB	OR	ON	2006/01/12 11:15
S20	1	(@ad<="20010312") and ((electrochemical\$4) adj (etch\$4)) and ((porous) adj (silicon)) and (438/745.ccls.) and (hydrogen)	US-PGPUB; USPAT; USOCR; EPO; JPO; DERWENT; IBM_TDB	OR	ON	2006/01/12 11:15

Day : Thursday  
Date: 1/12/2006


**PALM INTRANET**

Time: 14:08:48

**Inventor Name Search Result**

Your Search was:

Last Name = BOUKHERROUB

First Name = RABAH

Application#	Patent#	Status	Date Filed	Title	Inventor Name
<a href="#">09713300</a>	<a href="#">6677163</a>	150	11/16/2000	FUNCTIONALISED SILICON SURFACES, AND METHOD FOR THEIR PRODUCTION	BOUKHERROUB, RABAH
<a href="#">09803044</a>	<a href="#">6815162</a>	150	03/12/2001	PASSIVATION OF POROUS SEMICONDUCTORS	BOUKHERROUB, RABAH
<a href="#">10012943</a>	<a href="#">6814849</a>	150	12/10/2001	LUMINESCENCE STABILIZATION OF ANODICALLY OXIDIZED POROUS SILICON LAYERS	BOUKHERROUB, RABAH
<a href="#">10714972</a>	Not Issued	30	11/18/2003	Functionalised silicon surfaces, and method for their production	BOUKHERROUB, RABAH
<a href="#">10830035</a>	Not Issued	71	04/23/2004	Passivation of porous semiconductors	BOUKHERROUB, RABAH
<a href="#">10972550</a>	Not Issued	41	10/25/2004	Luminescence stabilization of anodically oxidized porous silicon layers	BOUKHERROUB, RABAH
<a href="#">60244929</a>	Not Issued	159	11/02/2000	Photooxide patterning on silicon	BOUKHERROUB, RABAH

Inventor Search Completed: No Records to Display.

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boukherroub
rabah
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# PALM INTRANET

## Inventor Name Search Result

Your Search was:

Last Name = WAYNER

First Name = DANIAL

Application#	Patent#	Status	Date Filed	Title	Inventor Name
<a href="#">09713300</a>	<a href="#">6677163</a>	150	11/16/2000	FUNCTIONALISED SILICON SURFACES, AND METHOD FOR THEIR PRODUCTION	WAYNER, DANIAL D. M.
<a href="#">10714972</a>	Not Issued	30	11/18/2003	Functionalised silicon surfaces, and method for their production	WAYNER, DANIAL D. M.
<a href="#">10972550</a>	Not Issued	41	10/25/2004	Luminescence stabilization of anodically oxidized porous silicon layers	WAYNER, DANIAL D. M.
<a href="#">60228770</a>	Not Issued	159	08/30/2000	Photopatterning of organics on silicon surfaces using a photo-oxide mask	WAYNER, DANIAL D. M.
<a href="#">60612168</a>	Not Issued	159	09/23/2004	Method and materials for the deposition and encapsulation of nanocrystals on surfaces	WAYNER, DANIAL D. M.
<a href="#">09691117</a>	Not Issued	161	10/19/2000	Nano-scale structures on surfaces	WAYNER, DANIAL D.M.
<a href="#">09803044</a>	<a href="#">6815162</a>	150	03/12/2001	PASSIVATION OF POROUS SEMICONDUCTORS	WAYNER, DANIAL D.M.
<a href="#">10012943</a>	<a href="#">6814849</a>	150	12/10/2001	LUMINESCENCE STABILIZATION OF ANODICALLY OXIDIZED POROUS SILICON LAYERS	WAYNER, DANIAL D.M.
<a href="#">10830035</a>	Not Issued	71	04/23/2004	Passivation of porous semiconductors	WAYNER, DANIAL D.M.
<a href="#">60244929</a>	Not Issued	159	11/02/2000	Photooxide patterning on silicon	WAYNER, DANIAL D.M.
<a href="#">60654517</a>	Not Issued	20	02/22/2005	Microfluidic microarray with high surface area active response	WAYNER, DANIAL D.M.
<a href="#">07775556</a>	Not Issued	161	10/15/1991	ELECTROCHEMICAL DEGRADATION OF CHLOROPHENOLS	WAYNER, DANIAL D.M.

Inventor Search Completed: No Records to Display.

Day : Thursday

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Time: 14:09:54

PALM INTRANET

**Inventor Name Search Result**

Your Search was:

Last Name = LOCKWOOD

First Name = DAVID

Application#	Patent#	Status	Date Filed	Title	Inventor Name
<a href="#">09890815</a>	Not Issued	125	02/06/2002	Computer borrow and loan securities auction system	LOCKWOOD, DAVID
<a href="#">60163303</a>	Not Issued	159	11/03/1999	COMPUTER BORROW AND LOAN SECURITIES AUCTION SYSTEM	LOCKWOOD, DAVID
<a href="#">06514597</a>	<a href="#">4529161</a>	150	07/18/1983	BREAK-AWAY MIRROR BRACKET	LOCKWOOD, DAVID G.
<a href="#">09695798</a>	<a href="#">6518603</a>	150	10/25/2000	SELECTIVE ELECTROCHEMICAL PROCESS FOR CREATING SEMICONDUCTOR NANO- AND MICRO-PATTERNS	LOCKWOOD, DAVID J.
<a href="#">09803044</a>	<a href="#">6815162</a>	150	03/12/2001	PASSIVATION OF POROUS SEMICONDUCTORS	LOCKWOOD, DAVID J.
<a href="#">10830035</a>	Not Issued	71	04/23/2004	Passivation of porous semiconductors	LOCKWOOD, DAVID J.
<a href="#">09196641</a>	<a href="#">6284671</a>	150	11/19/1998	SELECTIVE ELECTROCHEMICAL PROCESS FOR CREATING SEMICONDUCTOR NANO- AND MICRO-PATTERNS	LOCKWOOD, DAVID J.
<a href="#">60013336</a>	Not Issued	159	03/13/1996	LIGHT EMITTING DEVICES BASED ON SEMICONDUCTOR/DIELECTRIC SUPERLATTICE PHOSPHORS	LOCKWOOD, DAVID J.
<a href="#">10012943</a>	<a href="#">6814849</a>	150	12/10/2001	LUMINESCENCE STABILIZATION OF ANODICALLY OXIDIZED POROUS SILICON LAYERS	LOCKWOOD, DAVID JOHN
<a href="#">10972550</a>	Not Issued	41	10/25/2004	Luminescence stabilization of anodically oxidized porous silicon layers	LOCKWOOD, DAVID JOHN
<a href="#">10381746</a>	Not Issued	41	08/22/2003	Electrosurgery systems	LOCKWOOD, DAVID L.
<a href="#">06068945</a>	<a href="#">D260635</a>	150	08/23/1979	SPLIT CORE CURRENT	LOCKWOOD,

				TRANSFORMER	DAVID L.
<u>06647017</u>	<u>4672780</u>	150	09/04/1984	BUILDING PANELS	LOCKWOOD, DAVID N.
<u>06752027</u>	Not Issued	161	07/05/1985	DRILL BIT SHARPENING DEVICE	LOCKWOOD, DAVID N.
<u>06826061</u>	<u>4658549</u>	150	01/21/1986	DRILL BIT SHARPENING DEVICE	LOCKWOOD, DAVID N.
<u>07019330</u>	<u>4776139</u>	150	02/26/1987	BUILDING PANELS	LOCKWOOD, DAVID N.
<u>07217771</u>	<u>4862652</u>	150	07/11/1988	BUILDING PANELS	LOCKWOOD, DAVID N.
<u>07286621</u>	<u>4916867</u>	250	12/19/1988	DRILL BIT SHARPENER	LOCKWOOD, DAVID N.

Inventor Search Completed: No Records to Display.

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